

<p>Form PTO-1449</p> <p>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</p> <p>(Use several sheets if necessary)</p>				Document Number (Specifier)	Application Number	
				TSMC-02-1147	10/719,721	
				Applicant	Wen-Chi Chien	
				Filing Date	11/21/03	
				Group Art Unit		
U. S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE IF APPROPRIATE
SPS	6 564 113	5/13/03	Barto et al.	700	99	6/15/01
SPS	6 470 227	10/22/02	Rangachari et al.	700	95	12/2/98
SPS	6 259 959	7/10/01	Martin	700	99	9/4/98
SPS	6 128 588	10/3/00	Chacon	703	6	10/1/97
GM	5 826 238	10/20/98	Chen et al.	705	8	4/2/96
M	5 768 133	6/16/98	Chen et al.	364	468.01	3/19/96
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
OTHER DOCUMENTS (including Author, Title, Date, Page(s), Etc.)						
M	<p>"Understanding the Fundamentals of Kanban and Conwip Full Systems Using Simulation," Marek, et al., Proceedings of the 2001 Winter Simulation Conf. pp. 921-929, found on the web site <a href="http://www.informs-cs.org">www.informs-cs.org</a>, 6/12/03.</p>					
EXAMINER				DATE CONSIDERED		
				3/17/06		
<p>EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through entire row if citation is not being considered.</p>						

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.